

Challenge the next generation with ceramics!

Porous Chuck

Monolithic structure of porous and retainer
 NTK Ceratec developed unique technique
 manufacturing monolithic structure of porous
 cearmic and retaining body. This enables ultimate

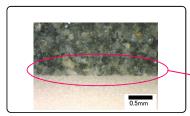
Various available option

The following material, pore size and porocity are available.

· Material : Al₂O₃, SiC

· Pore size: 5 , 10 , 30 , 70µm

Porocity: 30 ~ 60%





Both square and circle design are available. Any inside tunnel pattern is available.





Bonding strength between porous ceramics and retaining body is more than mechanical strength of porous ceramics.

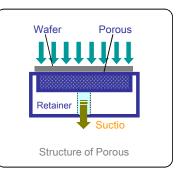
[Characteristics]

Material	A1203		SiC	
	Porous	Retainer	Porous	Retainer
Specific gravity	2.5	3.9	2.1	3.1
Bending Strength (MPa)	50	450	50	500
Young's modulus (GPa)	55	380	55	410
CTE (/°C)	7.4 × 10 ⁻⁶	7.3 x 10 ⁻⁶	4.7 x 10 ⁻⁶	4.6 × 10 ⁻⁶
Thermal Conductivity (W / m· K)	_	30	_	150
Volume Resistivity (Ω· cm)	1011	> 10 ¹⁴	106	106

[Application]

- Fixture of grinding Si Wafer(Dicing saw, Grinder, Polisher)
- Glass substrate carrier for LCD
- o Fixture for various test equipment
- o Fixing film sheet or metal substrate

[Example]



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This product specification and the catalog value are the references, and we may change of it without notice.

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